



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#16

Inventor: Patent Application	:	Group Art Unit: 1754
Garnier, <i>et al.</i>	:	
Serial Number: 09/582,049	:	Examiner: Nguyen, Ngoc Yen M.
	:	
Filed: September 1, 2000	:	Attn. Docket No.: Garnier-1
	:	
Title: Silicon Refining Method and Installation	:	Date: May 20, 2005
	:	
	:	

Commissioner for Patents
Washington, D.C. 20231

RECEIVED
MAY 26 2005
OFFICE OF PETITIONS

REPLY TO FINAL OFFICE ACTION

Sir:

This paper is responsive to the Office Action dated September 10, 2002. A petition for revival of an application abandoned unintentionally is included herewith. Kindly enter the following amendments:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.